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Kathi Howard July 6, 2005
Kathi Howard Date

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/607,018
Filed: June 27, 2003
Patent No.: 6,767,846
Issued: July 27, 2004
Applicant(s): Stanislaw Kopacz and John Lawson
Title: METHOD OF SECURING A SUBSTRATE IN A SEMICONDUCTOR PROCESSING MACHINE

Certificate
JUL 13 2005
of Correction

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

ATTN: DECISION AND CERTIFICATE OF CORRECTION
BRANCH OF THE PATENT ISSUE DIVISION

REQUEST FOR CERTIFICATE OF CORRECTION OF PATENT FOR PTO MISTAKE (37 CFR §1.322 (a)) AND APPLICANT'S MISTAKE (37 C.F.R. §1.323)

Sir:

Attached in duplicate form, is Form PTO-1050, with at least one copy being suitable for printing.

Many of the errors below are (or may be contended to be) the mistake of Applicant who states that the errors are of a minor nature in character and occurred in good faith, and correction thereof does not involve such changes in the patent as would constitute new matter or would

require reexamination. Some of the errors listed on the enclosed Form PTO-1050 were typographical errors which occurred through the fault of the U.S. Patent and Trademark Office ("PTO").

The exact column and line number where the errors are shown in the patent are as follows:

Cover page, Column 2, (ABSTRACT) reads "... support member and an ramp that is inclined such that the..." and should read - ... support member and a ramp that is inclined such that the... - .

Column 1, line 14 reads "...and, in particular, to a methods for a securing a substrate..." and should read - ... and, in particular, to a method for securing a substrate... - .

Column 1, lines 51-52 read "... rollers of the latches roll or slide over the rim of the wafer As the latches move to a latched position, excessive latching..." and should read - ... rollers of the latches roll or slide over the rim of the wafer. As the latches move to a latched position, excessive latching... - .

Column 2, lines 57-59 read "...inner peripheral flange when the latch body is in the latched position. (new paragraph) The clamping roller assembly has a resiliently-biased..." and should read - ...inner peripheral flange when the latch body is in the latched position. The clamping roller assembly has a resiliently-biased... - . (no new paragraph)

Column 3, line 22 reads "... member and an ramp that is inclined such that the clamping..." and should read - ... member and a ramp that is inclined such that the clamping ... - .

Column 3, lines 37-38 read "... the second surface in the effective to secure the substrate against the substrate-engaging surface." and should read - ... the second surface effective to secure the substrate against the substrate-engaging surface. - .

Column 6, lines 12-13 read "... arm (not shown) is inserting wafer 12 into, or removing wafer 12, from wafer holder 10. The construction and..." and should read - ... arm (not shown) is inserting wafer 12 into, or removing wafer 12 from, wafer holder 10. The construction and... - .

Column 8, line 9 reads "... the open end 78, rolling element 82 and a compression..." and should read - ... the open end 78. Rolling element 82 and a compression... - .

Column 8, line 11 reads "... cylindrical surface to 80 of sleeve 74 is dimensioned and ..." and should read - ... cylindrical surface 80 of sleeve 74 is dimensioned and... - .

Column 12, lines 5-6 read "... wafer 12. The clamp ring 100 is provided with a plurality of an upwardly-facing circular recesses, of which circular..." and should read - ... wafer 12. The clamp ring 100 is provided with a plurality of upwardly-facing circular recesses, of which circular... - .

Column 13, line 34 reads "... about 90° from cusped indent 148. Headed cylindrical..." and should read - ... about 90° from cusped detent 148. Headed cylindrical... - .

Column 13, line 40 reads "... 118, with the supporting roller assembly 28 rolling engaged..." and should read - ... 118, with the supporting roller assembly 28 rollingly engaged... - .

Column 13, line 58 reads "... 28 rolling engaged with the bottom surface 108 and transversing ..." and should read - ... 28 rollingly engaged with the bottom surface 108 and trasversing ... - .

Figure 6 reads "158" and should be - 150 - .

Please send the certificate to:

Donald F. Frei, Esq.
Wood, Herron & Evans, L.L.P.
2700 Carew Tower
Cincinnati, Ohio 45202

As some of the errors are, or could be contended to be, Applicant's mistakes, a check for \$100.00 to cover the correction fee is also enclosed. If there is any further charge or credit due, please use Deposit Account No. 23-3000.

Respectfully submitted,

WOOD, HERRON & EVANS, L.L.P.

By: 
Donald F. Frei, Reg. No. 21,190

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2700 Carew Tower
Cincinnati, Ohio 45202
(513) 241-2324

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 6,767,846 *h2*

DATED : July 27, 2004

INVENTOR(S) : Stanislaw Kopacz and John Lawson

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MAILING ADDRESS OF SENDER:

Wood, Herron & Evans, L.L.P.
2700 Carew Tower
441 Vine Street
Cincinnati, OH 45202-2917

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